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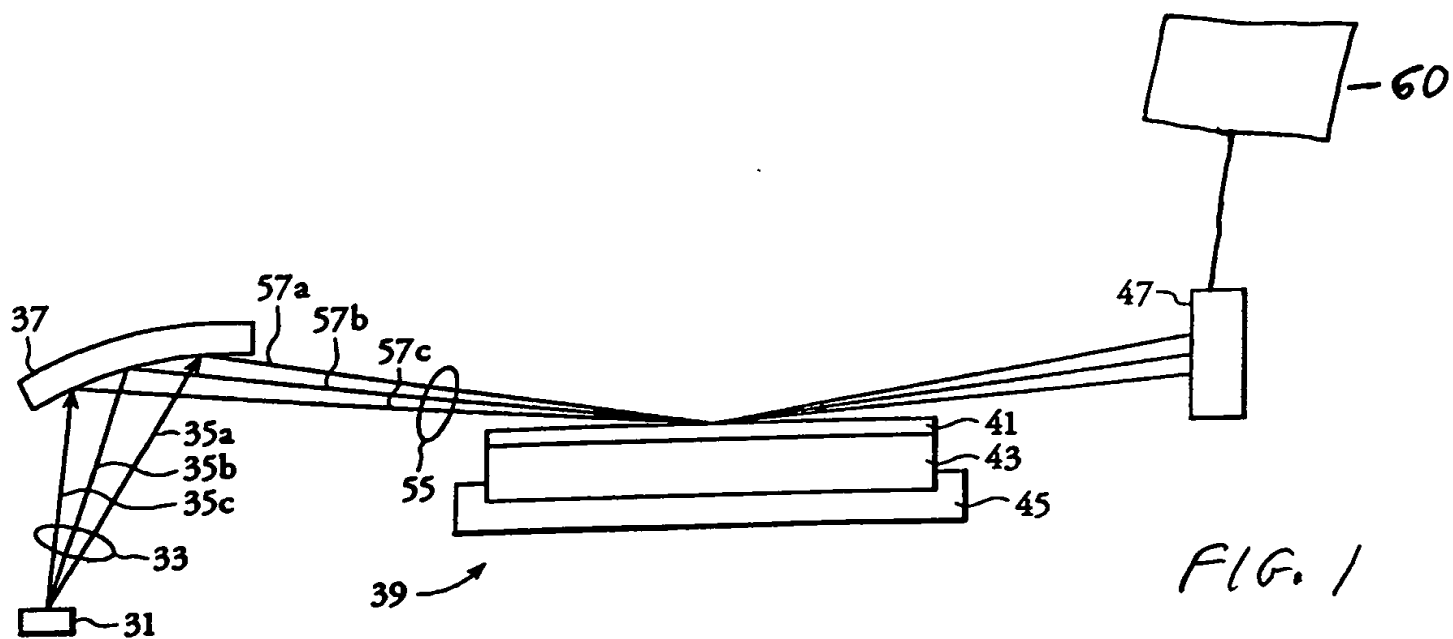


FIG. 1

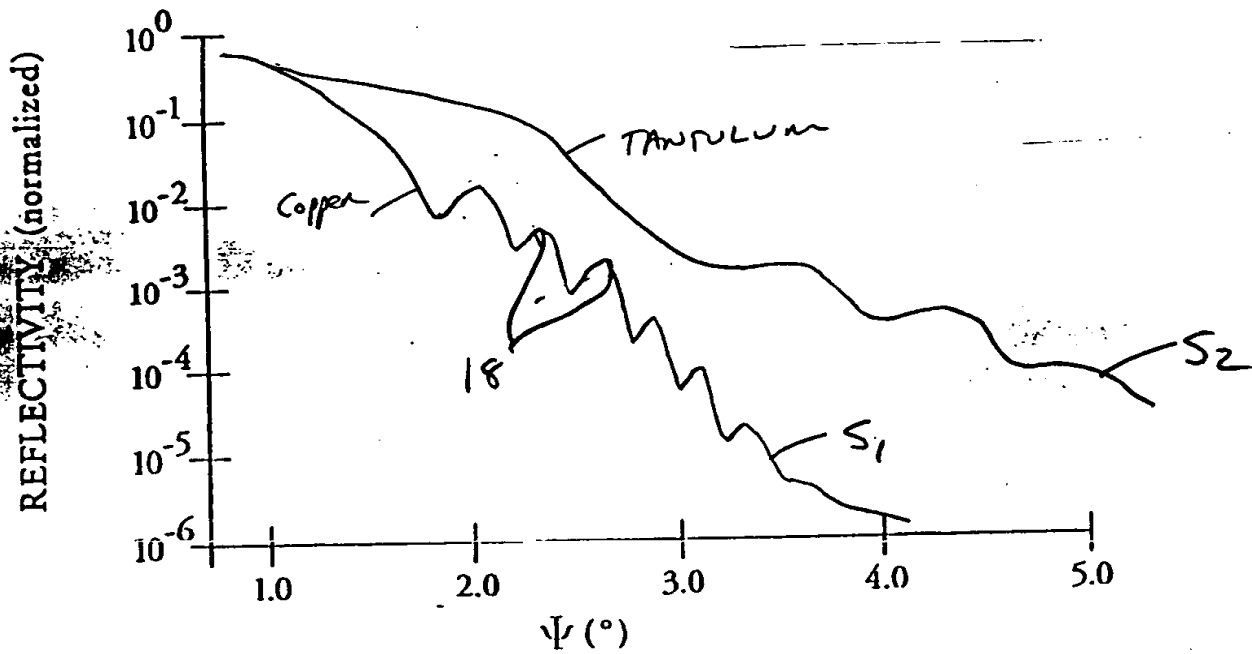


Fig 2

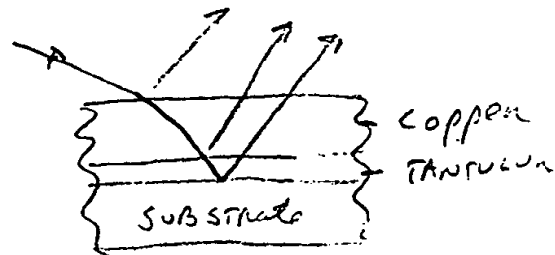
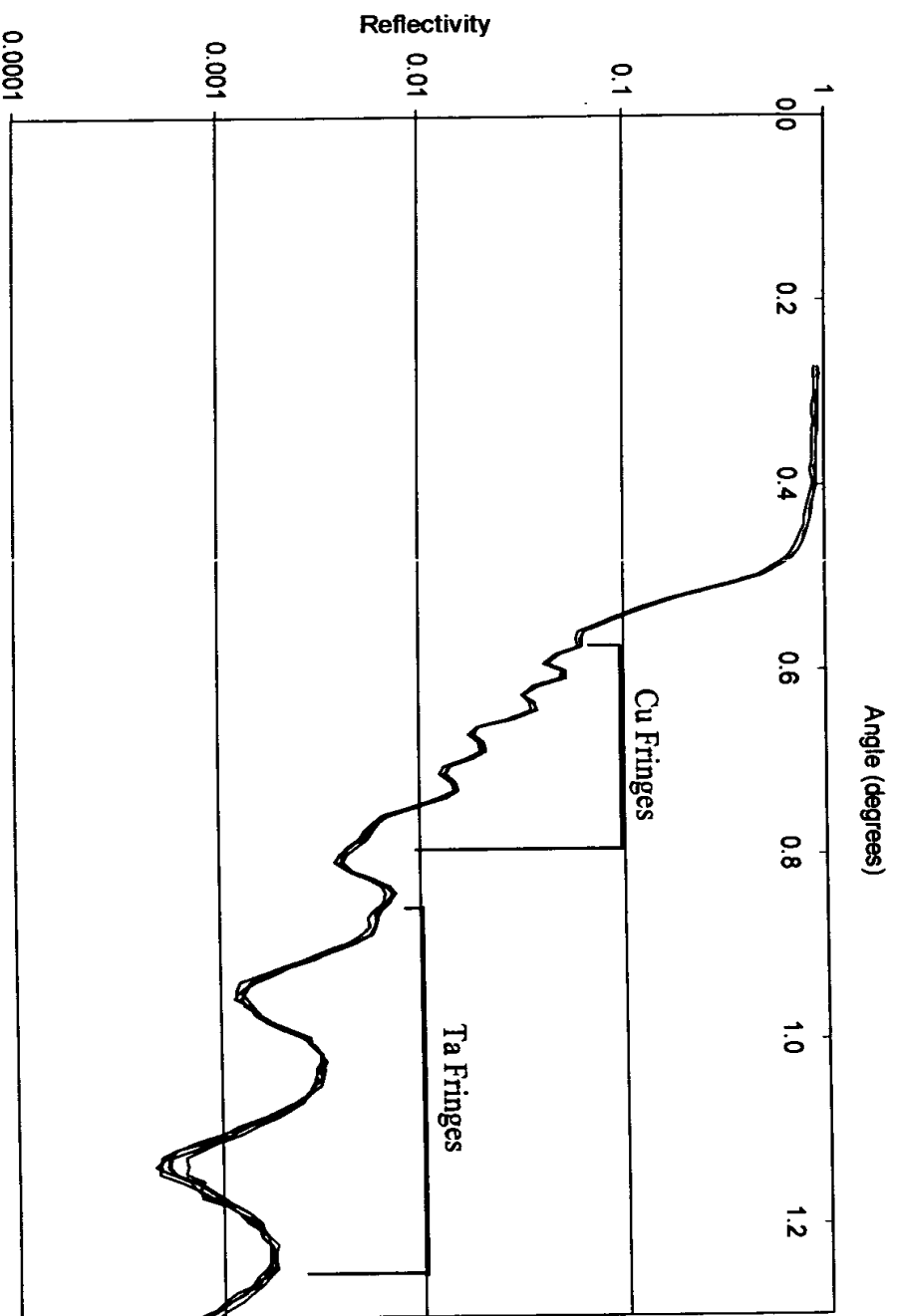


Fig 4

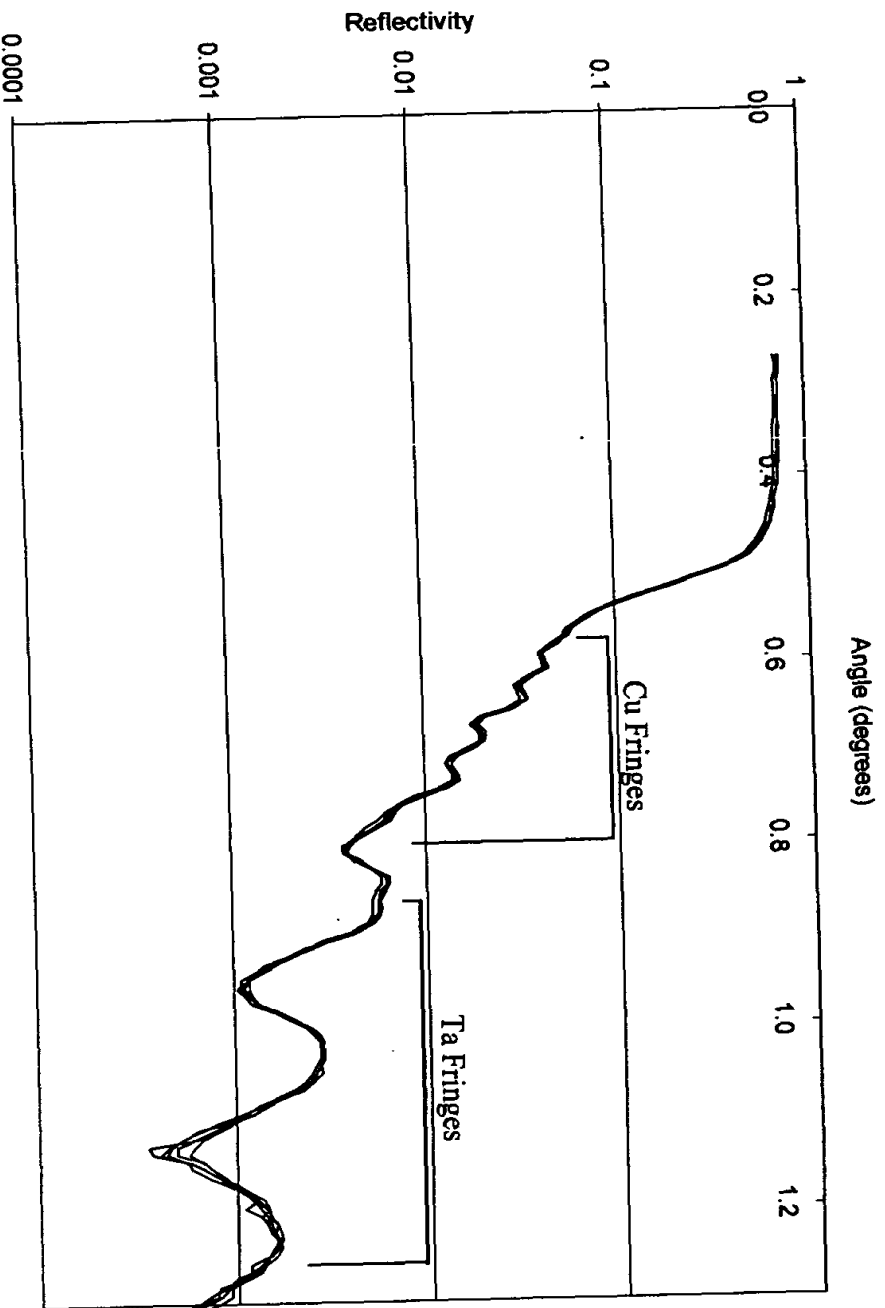
5 Measurements Over Same Area on Blanket Wafer (Cu Seed/Ta Barrier)



S3

Feb 16 3 28:10

5 Measurements Over Same Area on Patterned Wafer (Cu Seed/Ta Barrier)



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